## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:	) CONFIRMATION NO.: 1649
Masaru AMAI, et al.	)
U.S. Serial No.: 10/593,560	) Group Art Unit: 1792
Filed: September 20, 2006	) Examiner: Bibi S. Carrillo

For: SUBSTRATE CLEANING APPARATUS, SUBSTRATE CLEANING METHOD, AND

MEDIUM FOR RECORDING PROGRAM USED FOR THE METHOD

## RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir ·

A response to the Office Action mailed August 4, 2009 is due by September 4, 2009. The Action required restriction between two patentably distinct inventions.

Applicants hereby elect <u>Group II of claims 9-20</u>, drawn to a method, for examination in this application.

Applicants reserve the right to file divisional application(s) for the non-elected claims in due course.

It is submitted that this application now is in condition for examination on the merits and early action in that regard is solicited.

Respectfully submitted,

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